

FORM PTO-1449	Docket Number (Optional) 2080-3-189	Application Number 10/714,434
INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Applicant Tae Ho Kim, et al.	
	Filing Date November 12, 2003	Group Art Unit

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)
/DZ/	20010113441 A	12/28/2001	KOREA	G11B	12/02	YES (Abstract)
/DZ/	20010085515 A	09/07/2001	KOREA	H04L	12/40	YES (Abstract)
/DZ/	WO0914935	03/25/1999	WO	H04N		YES (Abstract)
/DZ/	WO9533309	12/07/1995	WO	H04L	12/64	YES (Abstract)

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	/Daquan Zhao/	DATE CONSIDERED	03/31/2008
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.